



Application of:
Sharan et al.

Serial No.: 09/825,612

Filed: April 3, 2001

For: METHOD FOR PECVD
DEPOSITION OF SELECTED
MATERIAL FILMS

§ Group Art Unit: 2829
§
§ Examiner: Lisa Kilday
§
§ Atty. Docket: 95-0716.01
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Certificate of Mailing (37 C.F.R. § 1.8)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on the date below:

1/13/03
Date

Susan Jerome
Signature

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136(a)

#8/24/03
MK
1/24/03

Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Applicant hereby petitions to extend the period for response to the Office Action mailed September 11, 2002 for one (1) month(s), from December 11, 2002 to January 11, 2003.

☒ Because January 11, 2003 falls on a Saturday in the District of Columbia, the period for response extends to January 13, 2003.

Accordingly, the requisite fee is \$ 110. The Commissioner is requested to charge this fee, and any additional fee which may be required, to Micron Technology, Inc. Deposit Account 13-3092, Order No. 95-0716.01. A duplicate copy of this petition is enclosed.

01/21/2003 SDENB081 00000092 133092 09825612
01 FC:1251 110.00 CH

Date: 1/13/03

Respectfully submitted,

Charles Brantley

Charles B. Brantley, II, Reg. No. 38,086
Micron Technology, Inc.
8000 S. Federal Way
Boise, ID 83706-9632
(208) 368-4557